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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Johannes Baur et al. Art Unit : 2812
Serial No. : 10/657,841 Examiner : Savitri Mulpuri
Filed : September 9, 2003
Title : RADIATION-EMITTING SEMICONDUCTOR COMPONENT AND METHOD
FOR PRODUCING THE SEMICONDUCTOR COMPONENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 18, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1-18-06

Date of Deposit

Cheryl A. Forrest

Signature

CHERYL A. FORREST

Typed or Printed Name of Person Signing Certificate